

RECEIVED  
CENTRAL FAX CENTER

MAR 11 2008

**TERNARY NITRIDE-BASED BUFFER LAYER OF A NITRIDE-BASED  
LIGHT-EMITTING DEVICE AND A METHOD FOR MANUFACTURING  
THE SAME**

Appl. No. : 10/711,567 Confirmation No. : 5566  
Applicant : Chen Ou,  
Wen-Hsiang Lin,  
Shih-Kuo Lai  
Filed : September 24, 2004  
TC/A.U. : 2822  
Examiner : GRAYBILL, DAVID E  
Docket No. : KYCP0029USA  
Customer No. : 27765

Commissioner for Patents  
P.O. Box 1450  
Alexandria VA 22313-1450

5

**AMENDMENT AND REQUEST FOR CONTINUED EXAMINATION**

Sir:

In response to the Office action of December 17, 2007, please amend the above-identified application as follows:

10 **Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Amendments to the Drawings** begin on page 5 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.

15 An **Appendix** including amended drawing figures is attached following page 8 of this paper.